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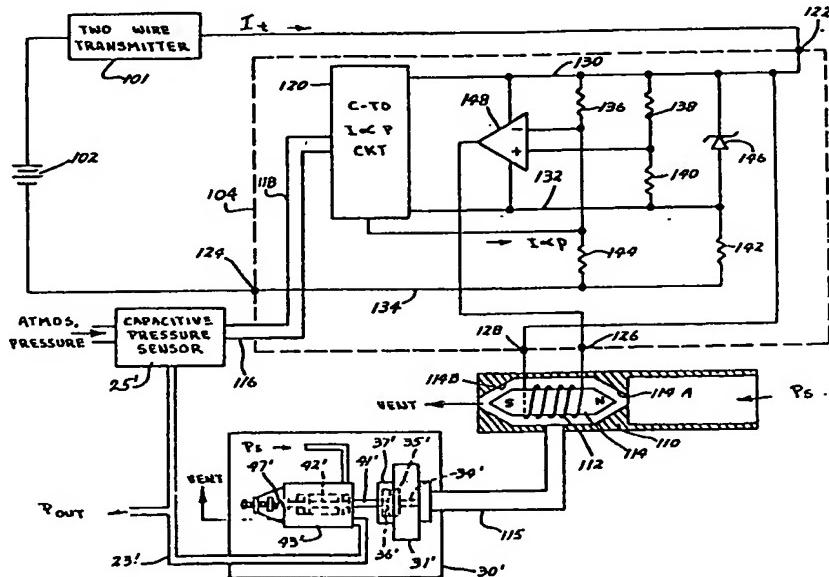
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(54) Title: CURRENT TO PRESSURE CONVERTER APPARATUS



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CURRENT TO PRESSURE CONVERTER APPARATUS

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention relates to current to pressure
5 transmitter apparatus.

2. Prior Art

Various electro pneumatic transducers which convert a
current signal into a pressure signal for controlling valves and
the like have been advanced. For example, Fischer Controls of
10 Marshalltown, Iowa makes several models, typical of which is the
Type 456 Electro Pneumatic Transducer. However, these devices
provide for a control pressure which utilizes an armature for
controlling a gas flow, and which gas flow in turn operates
a feedback diaphragm controlling the bleed of a supply of gas
15 under pressure to atmosphere.

An additional type of device which operates on a
similar principle, but which uses mechanical feedback is called
the E69 Series Current Pneumatic Converter Positioner made by
the Foxboro Company of Foxboro, Massachusetts.

20 Certain prior art current to pressure converters use
a type of a flapper valve controlling a flow from a nozzle, and
the use of a piezoelectric crystal as a flapper has also been
known in the prior art. U.S. Patent No. 3,456,669 illustrates
a piezoelectric flapper valve, operating in a transducer for pro-
25 viding current to pressure conversion. However, in this situation,
the flapper valve controls the exhaust of fluid from a chamber.
An additional piezoelectric bender element used for controlling
pressure outflow from nozzles is shown in U.S. Patent No. 3,063,422.

A control element using a flapper controlling nozzle
30 pressure output is shown in U.S. Patent No. 2,914,076, and a
bellows in this device operates a rheostat for providing a signal
indicating the pressure of the fluid being controlled.

An additional control apparatus using fluid pressure
signals is shown in U.S. Patent No. 2,928,409. Typical other
35 examples of this type of device include U.S. Patent No. 2,939,430
and 3,134,425.



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SUMMARY OF THE INVENTION

The present invention relates to a current to pressure transmitter operated in connection with a two wire controller providing a DC signal which controls the output of a pneumatic amplifier. The pneumatic amplifier includes a force balanced valve spool which may be directly actuated by a magnetic flux responsive movable element or by a pressure responsive movable wall or element.

As shown herein the opening of a pressure bleed nozzle or valve may be controlled by the DC signal. The pressure in the bleed nozzle or valve chamber determines the position of a diaphragm or similar mechanical element which is directly coupled to a spool of a gaseous fluid amplifier that provides the final control pressure.

The output control pressure of the gas amplifier is sensed and an electrical feedback signal representative of the output control pressure is provided and compared to the DC signal for controlling the DC signal and thus the output control pressure.

BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a block diagram representation of a current to pressure converter made according to the present invention;

Figure 2 is a top plan view of a pressure sensing and gas amplifying apparatus for a current to pressure transmitter made according to the present invention;

Figure 3 is a side view of the device of Figure 2 with parts in section and parts broken away;

Figure 4 is an enlarged sectional view of a spool valve gas type amplifier utilized with the device of Figure 2;

Figure 5 is a top plan view of a modified form of the device of Figure 2;

Figure 6 is a schematic representation of a modified form of the invention showing a magnetically controlled valve element; and

Figure 7 is a schematic showing of the fluid amplifier valve directly coupled to a magnetic coil actuator which is powered as shown in Figure 6.



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DESCRIPTION OF THE PREFERRED EMBODIMENTS

Referring first to Figure 1 for a schematic representation of the operation of this device, the current to pressure converter shown generally at 10 is an electric signal controlled apparatus using a directly controlled mechanically operated fluid amplifier. Converter 10 is used in connection with a process controller 8C which outputs a current along a pair of wires 8A and 8B to a two wire controller 11. A two wire current transmitter 8 provides a current which preferably is DC along a pair of wires 8D and 8E to the process controller 8C. The current provided along wires 8D and 8E is a function of a sensed parameter of a process variable 9 such as pressure, flow, temperature or the like. Typically process controller 8C will provide current from 4 to 20 or from 10 to 50 millamps across its range of operation.

The DC current provided by process controller 8C is used as a command signal to a two wire controller illustrated generally at 11. The output of controller 11 is a function of the current from the two wire transmitter and as shown provides a DC output from DC output means 11A. The circuit of the two wire controller is more fully explained in United States Patent Application Serial No. 94,444, filed on even date herewith (Attorney's Docket R11.2177). A typical two wire transmitter used in processes is shown in U.S. Patent No. 3,646,538. An output voltage from DC output means 11A is passed through lines 12 and 14 to the opposite sides of a "bimorph" blade or flapper type valve 13. A bimorph is formed of two piezoelectric plates cemented together with an insulator between the plates and oriented such that an applied voltage across the two piezoelectric plates causes one plate to expand and the other to contract so that the bimorph bends proportionally to the applied voltage. The bimorph flapper 13 bends an amount dependent upon the DC output voltage of DC output means 11A. The flapper 13 generally moves between its dotted and solid line positions shown in Figure 1. The amount of deflection of this bimorph flapper valve (other types of flapper valves may be utilized) controls the flow of gas from a nozzle assembly 16 and hence the pressure on the interior of the nozzle.



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Schematically a source of gas under pressure 17, such as a pneumatic compressor provides gas under pressure to nozzle assembly 16. A portion of the gas passes through an orifice 18, and out through a nozzle opening adjacent the flapper valve 13, which, because of its flexure, controls the pressure to a gaseous fluid amplifier 21 through conduit 21A. The fluid amplifier 21, as will be more fully explained, responds mechanically directly through a suitable diaphragm or other mechanical pressure transmitting element to control a valve which in turn controls a second portion of the fluid under pressure from the supply 17 which is supplied through a conduit 22. The output of the fluid amplifier 21 is a control pressure in a control pressure conduit 23 that is coupled to a fluid pressure responsive element in the process being controlled such as a pneumatic valve 20. The pneumatic valve controls a function in the process being monitored, which affects the process variable being sensed by transmitter 8. The adjustment of pneumatic valve 20 is made to bring the process variable back to a desired state. An exhaust pressure conduit 24 is provided as a bleed through the amplifier 21.

The control pressure conduit 23 not only carries the control pressure signal for operation of the controlled pneumatic valve 20, but also provides the control pressure signal to a pressure sensor 25, which in turn provides an electrical output signal along lines 26 to the two wire current controller 11 for feedback.

The feedback signal is compared with the input current signal from the process controller 8C and the control signal to DC output means 11A is stabilized at a level dependent upon the input signal and the feedback signal. Thus the bending of bimorph valve 13, and the resultant control pressure signal is responsive to the input signal from the two wire transmitter and process controller and the feedback signal provides indication of when the control pressure is at the proper level.

Figures 2-4 show details of the present device including a mounting block 30 utilized for supporting an upright column 31 which has a longitudinal passageway 32



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therein and which includes an orifice 18. Pressure from source 17 is coupled to passageway 32 and through the passageway to a nozzle pressure passageway 34 in block 31. The passageway 34 opens through nozzle 16 which is attached to block 31. The nozzle 16
5 has an outlet port or opening 33 through which gas (air) from source 17 is discharged.

The passageway 34 is also open to a chamber 35 defined in block 31 and which is closed by a flexible diaphragm or movable wall element 36, which is held in place on the block 31 with a
10 housing 37.

The flapper valve 13, as shown, is positioned adjacent the outlet port 33 of the nozzle 16, and pressure from supply 17 thus bleeds through the orifice passageway 32 and out through the port 33 and strikes the flapper valve 13, which is mounted for
15 bending movement with respect to a base 40 mounted on block 30. The upper end of flapper 13 is spaced from port 33 and will bend toward the port 33 to restrict flow out from the nozzle as voltage carried by lead wires 12 and 14 from the DC output means 11A of two wire controller 11 and applied to flapper 13 is increased.

20 In this embodiment a piezoelectric bimorph flapper 13 is utilized. However, other types of valves and flappers may be utilized such as magnetically actuated pivoting levers or other proportional flow valve devices. In any event the spacing between the surface of the flapper from the port 33 and the cross
25 sectional area of port 33 determine the volume of gas (air) that bleeds through the port 33. The flexure of flapper 13 controls the pressure in passageway 34 and thus the pressure in chamber 35. The position of the diaphragm 36 is a function of the pressure in chamber 35. A mechanical link 41, such as a dowel, is slidably
30 mounted through an aperture 36A in block 37 and is attached in a suitable manner to diaphragm or movable wall 36. The link 41, at its opposite end from the diaphragm 36, in turn is attached to the shaft portion of a valve element, as shown, a valve spool 42. Valve spool 42 is mounted in a valve spool housing 43. The valve
35 spool 42 includes a first land 44, and a second land 45. The opposite end of the valve spool 42 from the link 41 is indicated



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at 46, and the opposite end 46 is spring loaded with a compression spring 47. The compression of compression spring 47 is adjustable with an adjusting screw 50 that is threadably mounted with respect to upright supports 51 mounted onto a main support block 52, which 5 is mounted on block 30. Spring 47 acts against a washer 47A which is directly coupled to end 46 of valve spool 42 and provides a force urging spool 42 and diaphragm 36 in direction opposing the force of the gas under pressure acting on diaphragm 36. The support block 52 includes a pressure supply chamber 53 which is 10 connected to the pressure source 17, an output or control pressure chamber 54, and an exhaust passageway 55 or vent which leads to atmospheric pressure or other lower pressure area.

The valve spool housing 43 has an inlet or supply passageway 53A forming a port to valve spool 42 coupled to pressure 15 supply chamber 53, an output passageway 54A forming a control pressure port to the valve spool which connects with the chamber 54, and an exhaust passageway 55A forming an exhaust port to the valve spool, which connects to the exhaust passageway 55.

The movement of the valve spool 42, and, in particular, 20 lands 44 and 45, controls the amount of gas under pressure from the pressure supply 17 through chamber 53 and passageway 53A, which is diverted either through exhaust passageway 55A or the control pressure passageway 54A and out through the chamber 54, which is coupled to control pressure line 23 (shown in Figure 1). 25 The valve spool is a fluid proportioning device which regulates the output pressure as a function of position of valve spool 42.

The position of valve spool 42 initially in relation 30 to the diaphragm 36 can be adjusted by any desired means, and the compression of spring 47 can be adjusted so that the movement of the valve spool 42 can be related in a known manner to the pressure that is present in passageway 34. The system is an active system and when the flapper is in a reference position, there is pressure in chamber 35. The spring 47 is adjusted to 35 position the valve spool properly. The flapper 13, which is preferably a bimorph member, bends in relation to the electrical signal applied to it by the two wire current controller 11. The valve spool 42 also moves back and forth as the diaphragm 36



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moves when pressure in chamber 35 changes as determined by the position of flapper 13. The magnitude of movement of valve spool 42 is determined by the magnitude of the flapper movement, which is proportional to the voltage (electrical signal) along lines 5 12 and 14 and by the output pressure present. Dependent on the pressure integrity of the system, in equilibrium, spool 42 may be positioned such that lands 44 and 45 block both passageways 53A and 55A. That is, if the system were virtually pressure tight, the lands 44 and 45 could close both passageway 53A and 55A and 10 the pressure in the output conduit 23 would be maintained at the set present level, as required by the input signal. If however, there is a small leak in the system the spool valve and lands 44 and 45 may be in position to allow only a small amount of flow 15 to conduit 23.

Finally, if the leak is excessive, the lands 44 and 45 may be in position such that full flow is allowed, to sustain the pressure in conduit 23 at as close as possible to the desired pressure.

In the reference position of valve spool 42 the forces 20 on the valve spool are balanced (at equilibrium). That is the spring force from spring 47 is balanced by the force from diaphragm 36. Thus there is zero net force on the spool and any changes in pressure in chamber 35 caused by movement of flapper 13 results in a fast response of the valve spool 42. 25 The spring rate of spring 47 is selected so that the spool moves at a known relation to the amount of bending of the flapper valve 13. The control pressure preferably ranges from 3 to 15 psi, but other ranges may be used. Thus, at a 4 milliamp flow from the two wire transmitter 8 to the process controller 8C for example, 30 the control pressure preferably is 3 psi. The range for a 4-20 milliamp two wire transmitter would then be about 15 psi control pressure at full scale current (20 milliamps) from the two wire transmitter to the process controller.

In the second form of the invention shown in Figure 35 5, the flapper 13 has one end mounted on a support 67 and its opposite end is adjacent a nozzle 16 which corresponds to and is controlled in the same manner as nozzle 16 in the first



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form of the invention. The nozzle 16 exhausts fluid under pressure from pressure source 17 and the flapper 13 controls the pressure at the nozzle. However, in this instance, a bellows assembly indicated generally at 61 is provided on a mounting block 62, mounted on support 67, and the bellows has a movable actuating end wall or element 63. The bellows 61 is open to the interior of nozzle 16 and expands and contracts in direction as indicated by the double arrow 64 in relation to the amount of movement of the flapper 13, which controls the pressure within the bellows 61.

The actuator end wall 63 of the bellows bears against one end of a lever 65 which is pivotally mounted as at 66 on a pivot member mounted onto the support 67. The opposite end of the lever 65 as indicated at 68 has an actuator 68A bearing against one end of the valve spool 42 which is mounted in a valve housing 43, as shown in the previous form of the invention. The valve spool 42 is spring loaded or biased against the force generated by pressure in the bellows, also as explained in the previous embodiment. The spring load thus tends to resist expansion of the bellows 61 and the forces may be transferred to the lever and spool with only contact or bearing connections. If desired, the lever 65 can be pivotally connected to the actuator end wall 63 of the bellows and to valve spool 42.

The lever 65 affects the amount of valve spool movement for a given change of pressure caused by the change in the opening of flapper 13 relative to nozzle 16, and provides either a mechanical advantage for additional force for actuating the valve spool 42, or a motion advantage if desired.

The fluid amplifier assembly used with the device shown in Figure 5 includes the same components as previously described, and operates in the same manner to control the output or control pressure.

The pressure sensor 25 shown in Figure 1 could be replaced with a position sensor that would sense a position of an element in the process being controlled and provide a feedback signal that would be proportional to the movement or position of a control valve or similar device in the process. Devices



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that may be used as position sensors include LVDT'S, potentiometers, strain gages, synchros or other position encoding devices.

The diaphragm 36, mechanical link 41 and the valve spool and housing form parts of the fluid amplifier. The valve 5 spool and valve housing are existing valve members commercially available.

Figure 6 illustrates another preferred embodiment of the present invention which utilizes a magnetically controlled current to pressure transducer in place of the flapper valve 10 arrangement previously disclosed and also specifically showing a capacitive type feedback pressure sensor which corresponds to sensor 25 of Figure 1. As shown in Figure 6, a two wire transmitter and electronic two wire controller 104. The output of controller 15 and electronic two wire controller 104. The output of controller 114 is supplied as a current to a servo valve 110. The magnitude of the current supplied by controller 104 determines the magnetic field produced by a coil 112 of a servo or magnetic flapper valve 110, and thereby determines the position of a magnetic field responsive plunger or element 114 in relation to valve seats 114A. 20 When a magnetic flapper valve is used, a permanent magnet field biased by a magnetic field generated from a coil, such as coil 112, urges the ferro-magnetic flapper to a desired position. Such action is similar to the action of a permanent magnet DC motor. Input pressure P_S is supplied to the housing of servo valve 110 25 across valve seat 114A and the opening at valve seat 114B determines the amount of fluid flow to vent or exhaust and thus the pressure in the housing of servo valve 114 and the pressure in a valve output conduit 115. The pressure in line 115, which corresponds to line 21A in Figure 1, is thus determined by the 30 position of plunger 114 within the housing of servo valve 110.

In the embodiment shown in Figure 6, pressure sensor 25' is a capacitive pressure sensor which is preferably of the type described in previously-mentioned Frick Patent No. 3,646,538. Pressure sensor 25' compares the output pressure 35 P_{OUT} with atmospheric pressure. Output lines 116 and 118 from



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capacitive pressure sensor 25' are supplied to a capacitance to current as a function of pressure C-to-I \propto P circuit 120 within two wire controller 104. In a preferred embodiment of the present invention, C-to-I \propto P circuit 120 is of the type described in the previously mentioned Frick Patent No. 3,646,538 which provides a DC current output which varies in proportion to pressure sensed with a capacitance type pressure sensor.

Controller 104 has terminals 122 and 124 connected in series with two wire transmitter 101 and DC power source 102. Output terminals 126 and 128 of controller 104 are connected to coil 112 of servo valve 110.

Current I_t from two wire transmitter 101 is supplied to terminal 122, which is connected to first main conductor 130. A second main conductor 132 is also connected to circuit 120, and a third main conductor 134 is connected to terminal 124.

Controller 104 includes a bridge circuit formed by resistors 136, 138, 140, 142 and 144. Resistors 138 and 140 are connected in series between conductors 130 and 132. Resistor 142 is connected between conductors 132 and 134. Resistors 136 and 144 are connected between conductors 130 and 134.

Zener diode 146 establishes a reference voltage between conductors 130 and 132. The cathode of Zener diode 146 is connected to conductor 130, while its anode is connected to conductor 132.

Error amplifier 148 has its non-inverting input connected to the junction of resistors 138 and 140, and has its inverting input connected to the junction of resistors 136 and 144. The output of amplifier 148 is connected to output terminal 126. Conductors 130 and 132 are also connected to amplifier 148 to supply power.

Resistor 144 of the bridge circuit is a feedback resistor through which a feedback current $I \propto P$ flows. Current 120 is connected to the junction of resistors 136 and 124 to supply the feedback current $I \propto P$.

It can be seen, therefore, that the voltage supplied to the inverting input of amplifier 148 is a DC feedback signal which



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is a function of the output pressure P_{OUT} sensed by capacitive pressure 25'. The voltage supplied to the non-inverting input of amplifier 148 is a DC command signal which is a function of current I_t supplied by two wire transmitter 101.

- 5 When a change in current I_t occurs, the DC command signal voltage supplied to the non-inverting input of amplifier 148 changes, thereby creating an unbalance between the DC command and the DC feedback signals. Amplifier 148 slews in a direction determined by the relationship of the DC command and the DC
10 feedback signals, thereby changing the current supplied through terminals 126, 128 and coil 112 of servo valve 110. This causes a change in the position of plunger 114, thereby varying the output pressure P_{OUT} . This change in output pressure is sensed by capacitive pressure sensor 25', which supplies signals to circuit
15 120 over lines 116 and 118. The changing pressure sensed by capacitor pressure sensor 25' causes circuit 220 to change the feedback current $I_{\propto P}$ supplied to feedback resistor 144. This in turn changes the DC feedback signal voltage supplied to the inverting input of error amplifier 148. This process continues
20 until the DC feedback signal becomes equal to the DC command signal at the new balance point. The output of amplifier 148 then remains constant until another change in current I_t occurs.

The output pressure point may be used for adjusting some element in a process, such as a pneumatic valve or other
25 pneumatically controlled element.

The pressure in line 115 acts as an input to a gaseous fluid amplifier 21' which corresponds to the amplifier 21 in the previous forms of the invention. As schematically shown in Figure 6, the fluid amplifier includes the movable wall-valve arrangement as shown in Figures 2 through 4. To use the fluid amplifier arrangement of Figure 2-4, conduit 115 is connected to chamber 35 through passageway 34 shown in Figures 1 and 2, and passageway 32 is blocked off so that the pressure in conduit 115 from valve 110 would be pressure in chamber 35.

35 As shown in Figure 6, a mounting 30' supports an upright column or block 31' which has a chamber 35' defined therein. A



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passageway 34' opens to the chamber 35' and is also connected to the conduit 115. A flexible diaphragm or movable wall or element 36' shown in dotted lines in Figure 6 is held in place with a housing 37'. The wall 36' is connected to a mechanical link 5 such as a dowel indicated at 41' that is slidably mounted relative to the block 37' and is attached in a suitable manner at its opposite end from the wall 36' to a shaft portion of a valve element shown in dotted lines as a valve spool 42' in Figure 6. The valve spool 42' is mounted in a valve spool housing 43'. The valve spool 42' is spring loaded with a spring 47'. The spring load on 10 valve spool 42' can be adjusted in exactly the same manner as spool 42 shown in the previous forms of the invention. The valve spool is constructed to operate in the same way. Pressure supplies can be connected to the valve spool housing 43', and the 15 position of the valve spool 42' determines the amount of fluid discharging to the vent shown, or provided to an output conduit 23' that corresponds to the conduit 23 in the previous form of the invention. The position of the valve spool 42' is thus dependent upon the position of the movable wall or element 36', which is a 20 function of the pressure in conduit 115.

The apparatus as shown in Figure 6, includes a valve, with a magnetic field responsive actuated control element in place of the flapper valve assembly and thus can easily be adapted for use with the fluid amplifier illustrated in 25 Figures 2 through 4. The spring balanced valve spool 41, coupled to the movable wall or element 36' responds quickly to changes in pressure in conduit 115.

A further modified preferred embodiment of the present device, utilizing the circuit shown in Figure 6 is illustrated 30 in Figure 7. In this device, a magnetic actuator utilizes a magnetic force generated by a coil corresponding to the coil 112 in Figure 6. The actuator or movable member is used to directly actuate the valve spool 42', and the need for a movable wall or diaphragm is obviated. The force balanced valve spool 35 42' moves very smoothly, with low external force requirements. The spring balancing, or biasing of the spool fulfills the need



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for a low force requirement actuator quite well.

Referring specifically to Figure 7, the valve body 43' is illustrated, and includes pressure supply input labeled P_S , and the output pressure conduit 23' which leads to the 5 capacitive pressure sensor 25' and also provides the output control pressure to various control devices. The valve spool 42' is shown in dotted lines, and it is spring balanced with the spring 47' also as shown in this particular form of the invention.

10 The terminals 128 and 126 of the circuit of Figure 6 are connected to a coil 129 which acts on a fixed magnetic actuator member illustrated schematically at 131. The actuator 131 provides a permanent magnetic field and also provides magnetic forces resulting from current in the coil 129. The 15 actuator 131 is coupled magnetically to an outwardly extending actuator portion 133 of the valve spool 42'. This results in an action on the actuator portion 133 and spool 42' similar to the action of a permanent magnet motor to control movement of valve spool 42'. The magnetic actuator 131 takes the place of 20 the dowel or link 41' in the form of the invention of Figure 6. The actuator 131 can be mounted in suitable supports relative to the coil 129, and the valve spool 42' will move as a function of the magnetic flux developed by the coil 129 from the current through terminals 126 and 128.

25 Thus, in a reference position, the spring 47' will be set to provide for the balance of the valve spool 42' as in the previous forms of the invention. Changes in the current at terminals 126 and 128 will cause a change in the magnetic force from actuator 131 and this will cause the spool 42' to shift. 30 The spring 47' then can be selected in rate to correlate to the forces being generated by the coil 129.

The same movements of valve spool 41' would occur as previously described. The valve spool would be shifted as a function of the input current to the circuit of Figure 6. The 35 resulting pressure at conduit 23' is used for operating control elements and also is sensed at the capacitive pressure sensor 25' shown in Figure 6 for providing a feedback signal. In many in-



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stances the Figure 7 device is preferred because its direct action permits the limitation of the movable wall portion of the system shown in Figure 6.

Precise control and adequate outputs are provided
5 with the device of the various embodiments shown herein.



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WHAT IS CLAIMED IS:

1. A current to pressure converter apparatus including:
means providing an input electrical signal;
circuit means responsive to said input electrical
5 signal to provide an output DC electrical
signal;
coil means connected to receive the output DC
electrical signal;
means responsive to said output DC electrical
10 signal including a magnetic linearly
movable element, the amount of movement
of which is a function of the DC output
electrical signal received by the
coil means;
15 said means responsive to the output DC electrical
signal further including a fluid amplifier
means having an outlet and including a
valve spool movable to position to adjust
the fluid pressure at the outlet;
20 means to mechanically couple the movable element
to said valve spool so movement of the movable
element moves said valve spool and controls the
position thereof as a function of the output
DC electrical signal in said coil means; and
25 means to provide a DC electrical feedback signal to
said circuit means which is a function of the
fluid pressure at the outlet of the fluid
amplifier means and to combine the DC electrical
feedback signal with the input electrical
30 signal so that the output DC electrical signal
is a function of the input and DC feedback
electrical signals.
2. The apparatus of Claim 1 and a chamber having
a movable wall deflectable under fluid pressure, said movable
35 element controlling fluid pressure on the wall to thereby control
the movement of said movable wall, and means to couple the



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movable wall to the valve spool.

3. The apparatus of Claim 1 further including bias means biasing the valve spool in a first direction.

4. The apparatus of Claim 3 wherein the bias means comprises a spring acting on said valve spool, and means to adjust the force exerted on said valve spool at a referenced position by the bias means.

5. The apparatus of Claim 1 wherein fluid amplifier includes an exhaust port means and said valve spool controls flow from a source of fluid under pressure to the outlet and to the exhaust port means.

6. The apparatus of Claim 2 wherein said movable wall comprises a diaphragm member having a peripheral edge, and a peripheral wall supporting said edge.

15 7. The apparatus of Claim 6 wherein the means to couple the movable wall to said spool valve comprises:

a link connected to said movable wall at one end thereof and directly connected to said spool valve at an opposite end thereof.

20 8. The apparatus of Claim 6 wherein the means to couple comprises:

a lever pivotally mounted relative to said movable wall and said valve spool, one end of said lever being mechanically coupled to said valve spool and a second end of said lever being coupled to said movable wall.

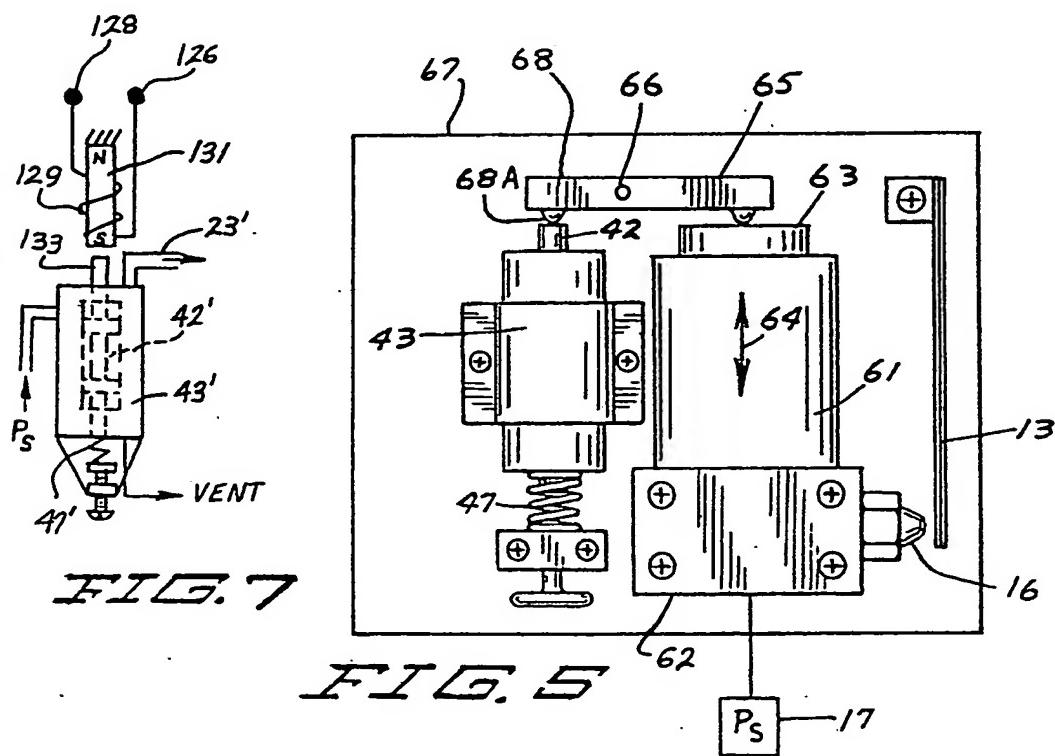
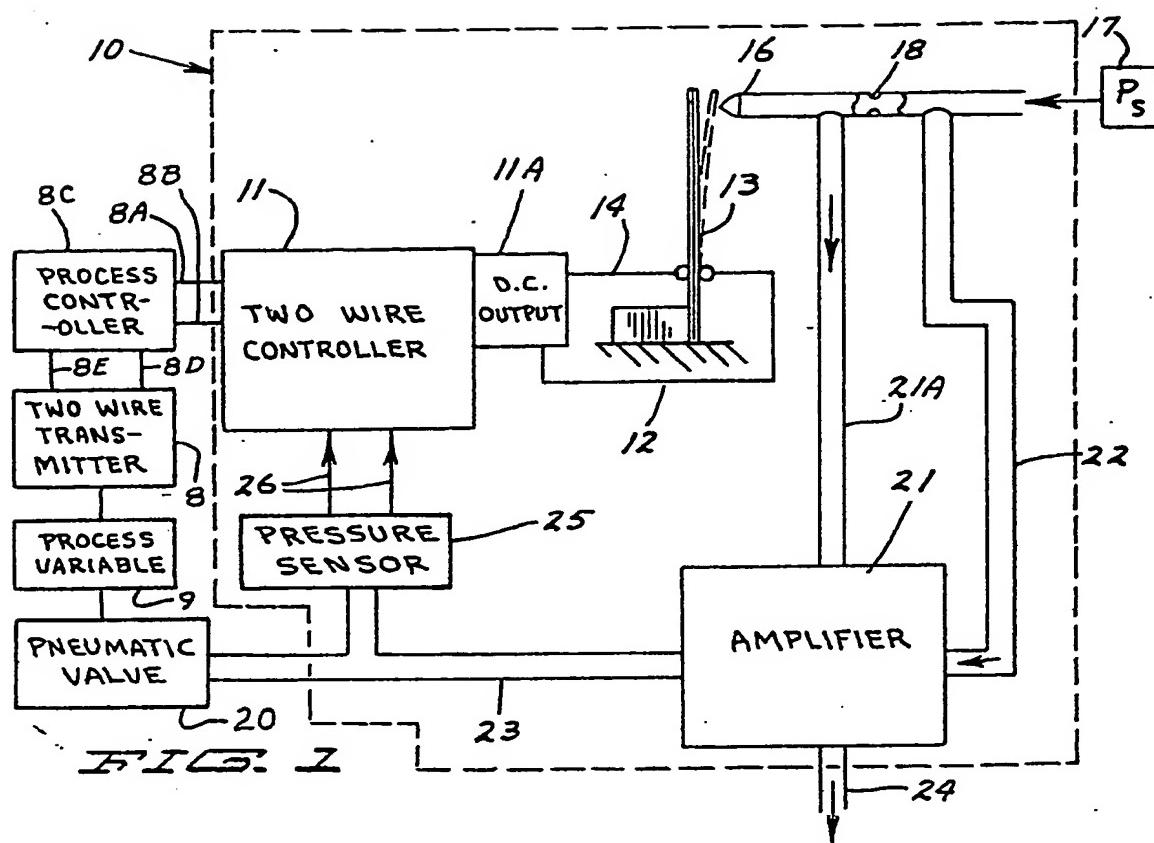
9. The apparatus of Claim 2 wherein said means to couple the movable wall to the spool valve comprises a link capable of carrying tension and compression loads.

30 10. The apparatus of Claim 1 wherein the coil means comprises at least one coil having a central axis and said linearly movable element moves in direction along said axis.

35 11. The apparatus of Claim 1 wherein said linearly movable element comprises an actuator portion forming a part of the valve spool.

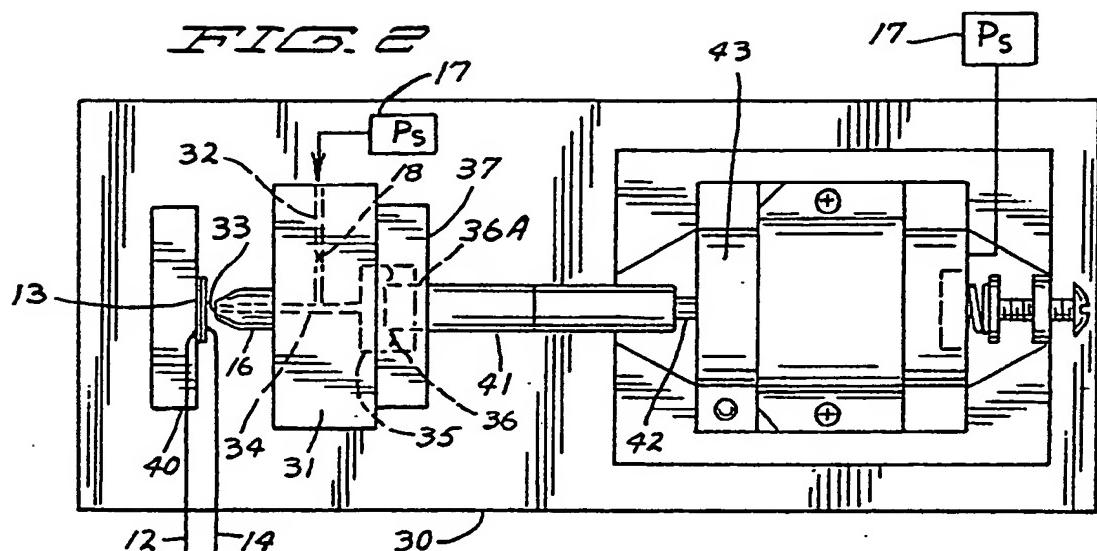


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FIG. 2



17 — Ps

FIG. 3

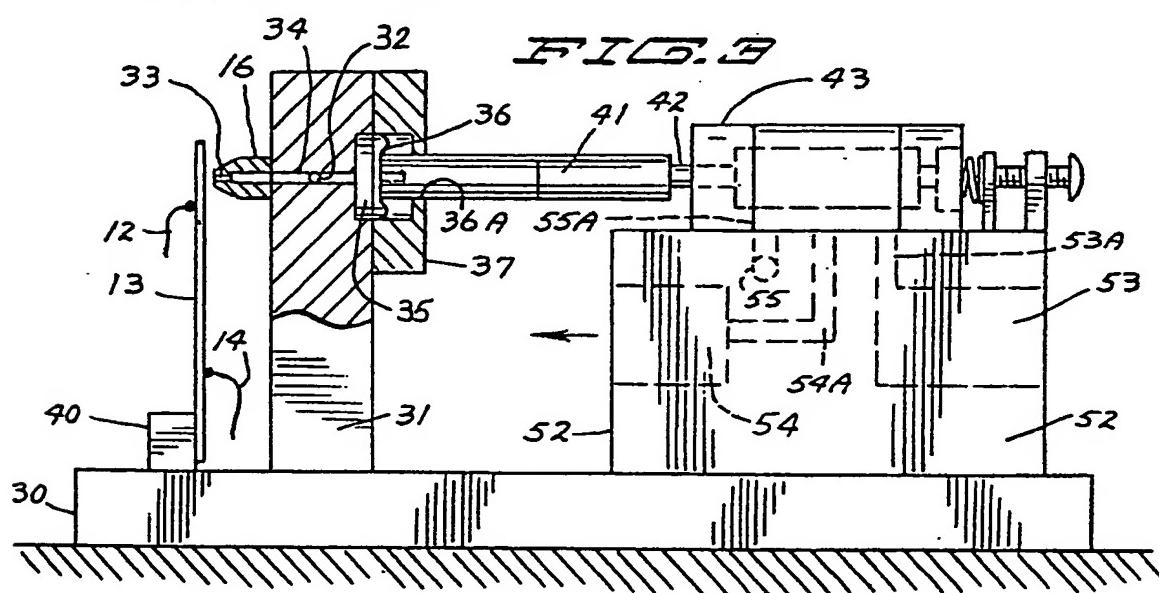
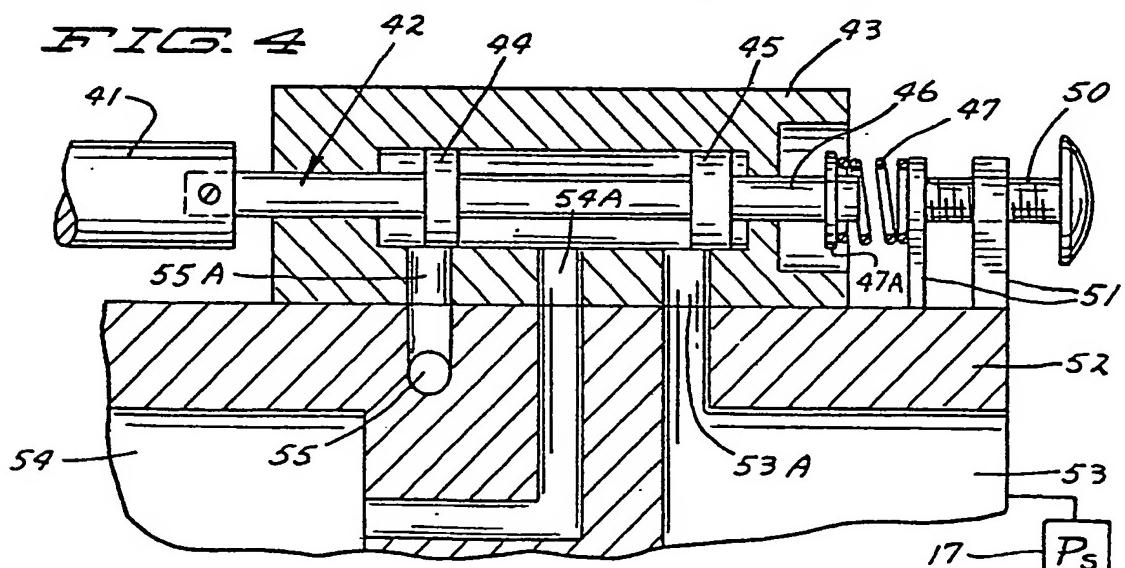
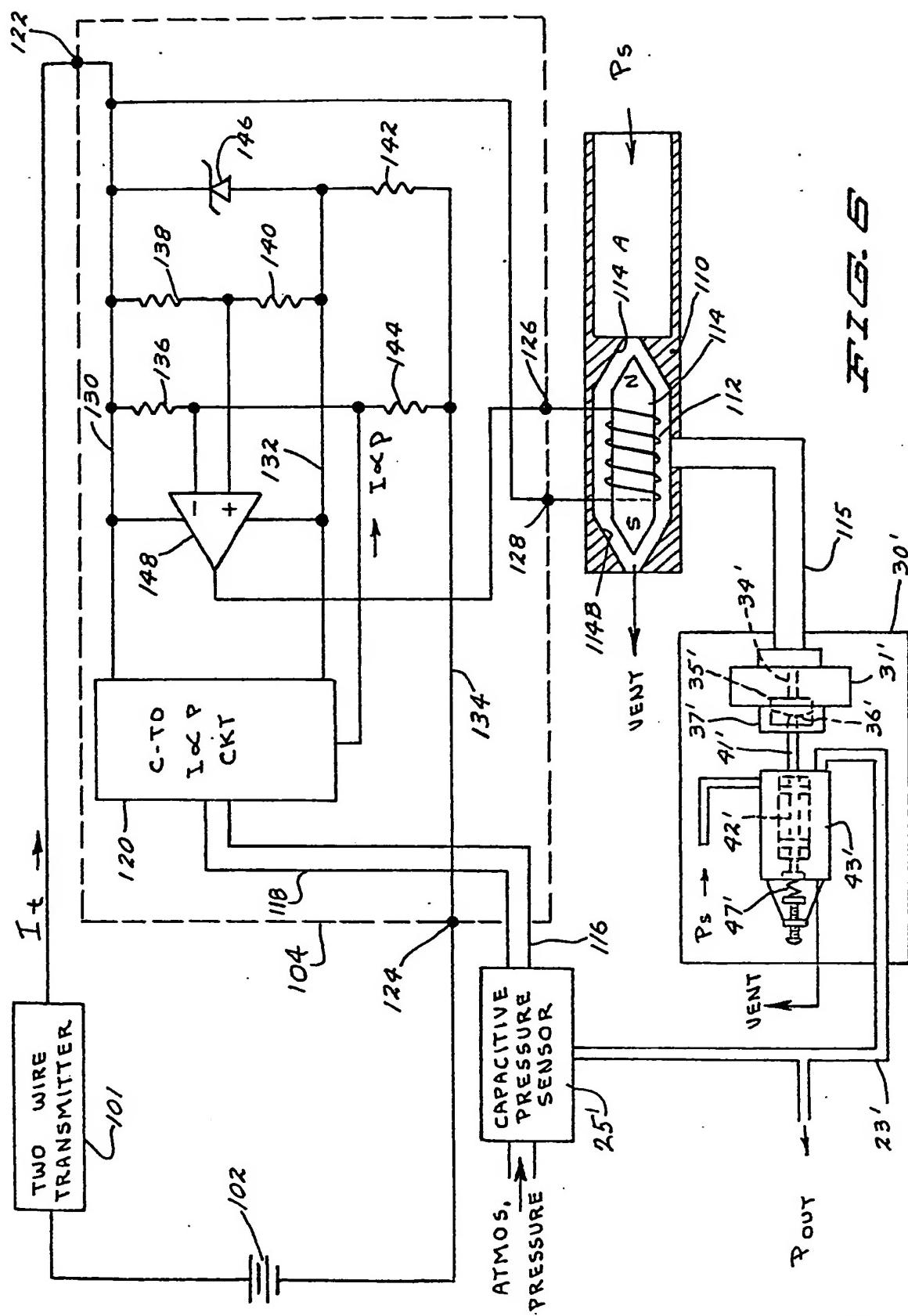


FIG. 4



BUREAU
OMPI
WIPO

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INTERNATIONAL SEARCH REPORT

International Application No. PCT/US80/01524

I. CLASSIFICATION OF SUBJECT MATTER (If several classification symbols apply, indicate all) *

According to International Patent Classification (IPC) or to both National Classification and IPC
INT. CL. G05D 16/20

U.S. CL 137/85

II. FIELDS SEARCHED

Minimum Documentation Searched *

Classification System	Classification Symbols
U.S.	137/84, 85, 486, 487.5, 625.64, 625.66

Documentation Searched other than Minimum Documentation
to the Extent that such Documents are Included in the Fields Searched *

III. DOCUMENTS CONSIDERED TO BE RELEVANT **

Category *	Citation of Document, ¹⁹ with indication, where appropriate, of the relevant passages ¹⁷	Relevant to Claim No. ¹⁸
A	US, A 2,505,981 PUBLISHED 2 MAY 1950 McLOED	1-11
A	US, A 2,842,147 PUBLISHED 8 JULY 1958 MARKSON	1-11
A	US, A 2,917,064 PUBLISHED 15 DECEMBER 1959 HUNTER	1-11
A	US, A 2,928,409 PUBLISHED 15 MARCH 1960 JOHNSON	1-11
A	US, A 2,939,430 PUBLISHED 7 JUNE 1960 WESTBURY	1-11
A	US, A 2,941,723 PUBLISHED 21 JUNE 1960 SEVERN'S	1-11
X	US, A 2,993,497 PUBLISHED 7 JULY 1961 COLES	1,2,3,5,6,7,11
A	US, A 3,063,422 PUBLISHED 13 NOVEMBER 1962	1-11
A	US, A 3,113,582 PUBLISHED 10 DECEMBER 1963 HUDSON	1-11
A	US, A 3,456,699 PUBLISHED 22 JULY, 1969 LLOYD	1-11

* Special categories of cited documents: ¹⁶

"A" document defining the general state of the art

"E" earlier document but published on or after the International filing date

"L" document cited for special reasons other than those referred to in the other categories

"O" document referring to an oral disclosure, use, exhibition or other means

(Continued)

**P= document published prior to the International filing date but on or after the priority date claimed

**T= later document published on or after the International filing date or priority date and not in conflict with the application, but cited to understand the principle or theory underlying the invention

**X= document of particular relevance

IV. CERTIFICATION

Date of the Actual Completion of the International Search ¹

6 JANUARY 1981

Date of Mailing of this International Search Report ²

22 JAN 1981

International Searching Authority ¹

RC/US

Signature of Authorized Officer ¹⁰

ALAN COCHAN

FURTHER INFORMATION CONTINUED FROM THE SECOND SHEET

A	US,A 3,625,246 PUBLISHED 7 DECEMBER 1971, REAVES	1-11
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V. OBSERVATIONS WHERE CERTAIN CLAIMS WERE FOUND UNSEARCHABLE¹⁰

This international search report has not been established in respect of certain claims under Article 17(2) (a) for the following reasons:

1. Claim numbers _____, because they relate to subject matter¹¹ not required to be searched by this Authority, namely:

2. Claim numbers _____, because they relate to parts of the international application that do not comply with the prescribed requirements to such an extent that no meaningful international search can be carried out¹², specifically:

VI. OBSERVATIONS WHERE UNITY OF INVENTION IS LACKING¹³

This International Searching Authority found multiple inventions in this international application as follows:

1. As all required additional search fees were timely paid by the applicant, this international search report covers all searchable claims of the international application.
2. As only some of the required additional search fees were timely paid by the applicant, this international search report covers only those claims of the international application for which fees were paid, specifically claims:
3. No required additional search fees were timely paid by the applicant. Consequently, this international search report is restricted to the invention first mentioned in the claims; it is covered by claim numbers:

Remark on Protest

- The additional search fees were accompanied by applicant's protest.
- No protest accompanied the payment of additional search fees.